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Steven M. Rabin
Robert H. Berdo, Jr.
Phillip G. Avruch
Allen Wood
Qixia Zhang, Pat. Agent (China)

Suite 500, 1101 14th Street, N.W.
Washington, D.C. 20005
Tel.: (202) 371-8976 Fax: (202) 408-0924
E-Mail: firm@rabinchamp.com

In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
and in Washington, DC with
Rabin & Berdo, PC

December 31, 2003

13281 U.S.PTO

17510 U.S.PTO
10/748240

123103

Mail Stop Patent Application

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attorney Reference: OKI 395

Re: New Patent Application of: Ryoichi AOYAMA, Toshio ONODERA,
Yasuhiro YAMAMOTO and Daigo HOSHINO

Title: SELF-CLEANING METHOD FOR SEMICONDUCTOR EXPOSURE
APPARATUS

Sir:

Please find attached hereto an application for patent which includes:

- [x] Specification, Claims and Abstract (25 Pages)
- [x] 7 Sheets of Formal Drawings (Fig. 1 through Fig. 6B)
- [x] Inventor's Declaration and Power of Attorney (4 Pages)
- [x] Assignment document with cover page (3 Pages)
- [x] Claim for priority and the Priority document
- [x] Information Disclosure Statement, Form PTO-1449, and copies of three references
- [x] Form PTO-2038
- [x] Fee (see formula below)

Basic Fee \$770/385 \$ 770.00

Additional Fees:

Total number of claims: 10 \$ 0.00
in excess of 20: 0 times \$18/9

Number of independent claims: 3 \$ 0.00
in excess of 3: 0 times \$86/43

Multiple Dependent Claims \$290/145 \$ 0.00

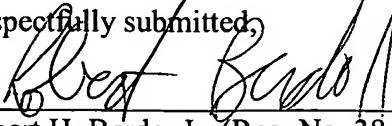
Recording Fee \$40. \$ 40.00

TOTAL FEES FOR THE ABOVE APPLICATION \$ 810.00

In the event there is attached hereto no credit card form PTO-2038 or check, or there is an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of Japanese Application No. 2003-148076, filed May 26, 2003.

Respectfully submitted,



Robert H. Berdo, Jr. (Reg. No. 38,075)
(Customer No. 23995)

December 31, 2003

Date

RHB:tz